

#10  
AS  
4/20/02

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE


Application Serial No. .... 09/360,292  
Filing Date .... July 22, 1999  
Inventor .... Sujit Sharan et al.  
Assignee .... Micron Technology, Inc.  
Group Art Unit .... 1746  
Examiner .... Ahmed, Shamim  
Attorney's Docket No. .... MI22-1106  
Title: Plasma Etching Process

Assistant Commissioner of Patents

Washington, D.C. 20231

ASSOCIATE POWER OF ATTORNEY

Please recognize Jennifer J. Taylor, Ph.D. (Reg. No. 48,711), Frederick M. Fliegel, Ph.D. (Reg. No. 36,138), D. Brent Kenady (Reg. No. 40,045), and James E. Lake (Reg. No. 44,854), whose post office address is 601 W. First Avenue, Suite 1300, Spokane, Washington 99201-3828, as an associate attorney or agent in the above-entitled application.

Date: 4-15-02  
Mark S. Matkin  
Reg. No. 32,268OFFICIAL  
FAX RECEIVED  
APR 16 2002  
GROUP 1700